This is a translation of the Swedish, legally binding, course syllabus.

If the course is discontinued, students may request to be examined during the following two academic years

**Establishment**

Course syllabus for FEK3212 valid from Spring 2019

**Grading scale**

P, F

**Education cycle**

Third cycle

**Specific prerequisites**

**Language of instruction**

The language of instruction is specified in the course offering information in the course catalogue.

**Intended learning outcomes**

After the completed course the student shall be able to:

- Report on various ongoing international researches in MEMS.
• Describe some application examples and/or commercial applications of MEMS.
• Review various applications and research of MEMS outside the student’s own research field.

Course contents

The course consists of seminars given by internal or external lecturers. Lectures will cover topics such as current MEMS research presented at international conferences, commercial applications of MEMS or other topics related to MEMS research and application.

Examination

• EXA1 - Examination, 2.0 credits, grading scale: P, F
Based on recommendation from KTH’s coordinator for disabilities, the examiner will decide how to adapt an examination for students with documented disability.

The examiner may apply another examination format when re-examining individual students.

Active participation at at least ten seminars is required.

Other requirements for final grade

Active participation at at least ten seminars is required.

Ethical approach

• All members of a group are responsible for the group's work.
• In any assessment, every student shall honestly disclose any help received and sources used.
• In an oral assessment, every student shall be able to present and answer questions about the entire assignment and solution.